



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 5, 2026	
IGI Report Number	LG772603585
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	8.22 X 5.82 X 3.60 MM

GRADING RESULTS

Carat Weight	1.10 CARAT
Color Grade	E
Clarity Grade	VS 1

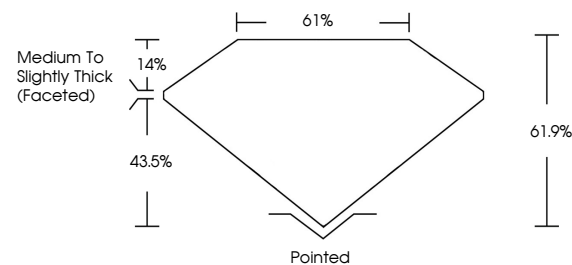
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG772603585

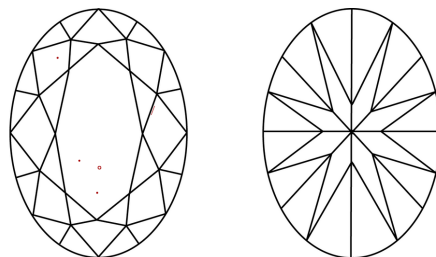
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG772603585
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

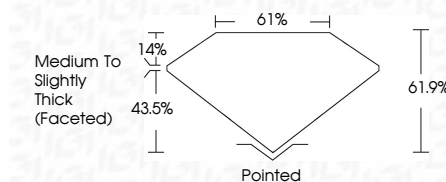
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February 5, 2026	1.10 CARAT
GI Report No. I5772603585	E
GLOBAL BRIGHT	VS1
	61.9%
	61%
	Medium to slightly thick Feared
	poorly
	EXCELLENT
	EXCELLENT
	NONE
	see I5772603585

Comments:
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(CVD) growth process.

www.igi.org